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NO. 6002 P. 1/53

1FW

Attorney Docket No. 03663/LH

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicants : Tomio MATSUZAKI et al
Serial No. : 10/700,136
Filed : November 3, 2003
For : WIRING STRUCTURE ON
SEMICONDUCTOR SUBSTRATE
AND METHOD OF FABRICATING
THE SAME
Art Unit : 2811
Examiner : PAREKH, Nitin
Customer No.: 01933
Confirm. No.: 3722

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR 1.97(d) WITH STATEMENT UNDER
37 CFR 1.97(e) AND FEE UNDER 37 CFR 1.17(p)**

MAIL STOP: ISSUE FEE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R :

Submitted herewith are the following:

- (1) A Japanese Office Action (Notification of Reasons for Rejection) dated May 15, 2007 (and English translation thereof), issued in counterpart Japanese Patent Application No. 2003-147447;
- (2) Copies of cited publications;
- (3) IDS Form; and
- (4) A Form 2038 is enclosed to cover the USPTO fee of \$180.00 as set forth under 37 CFR 1.17(p) for filing an IDS at this stage of prosecution (after allowance and before payment of the Issue Fee).

**CERTIFICATE OF FACSIMILE
TRANSMISSION
TO NO. 1-571-273-8300**

TOTAL PAGES: **53**

I hereby certify that this paper is being facsimile transmitted to the Commissioner for Patents, on the date noted below.

Diane J. Hegstrom
Diane J. Hegstrom

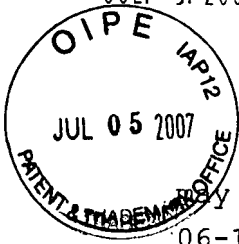
Dated: July 5, 2007

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed concurrently herewith, please consider this as a Petition for the requisite extension of time, and to the extent not tendered by credit card payment, authorization to charge the extension fee, or any other fee required in connection with this Paper to Account No. 06-1378.

07/06/2007 HDEMESS2 00000030 10700136

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Authorization is given to charge any additional fees which may be required, or to credit any overpayment, to Account No. 06-1378.

An English translation of said Japanese Office Action is provided, thereby satisfying the requirements for a concise explanation of relevance for any non-English language publications cited therein (MPEP 609.04(a)III).

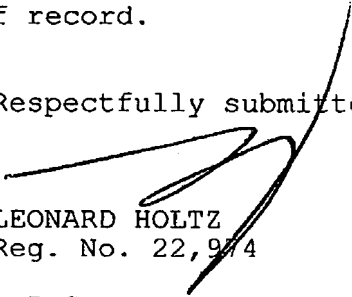
STATEMENT UNDER 37 CFR 1.97(e)

Each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the present Information Disclosure Statement. Said Communication bears a mailing date of May 15, 2007.

The filing of this Information Disclosure Statement is timely under the provisions of 37 CFR 1.97(d).

It is requested that an initialed copy of the IDS Form returned to indicate that the publications listed therein have all been considered and made of record.

Respectfully submitted,


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IDS FORM INFORMATION DISCLOSURE STATEMENT BY APPLICANT	U.S. Serial No.	10/700,136
	Filing Date	November 3, 2003
	First Named Inventor	Tomio MATSUZAKI et al
	Group Art Unit	2811
	Examiner Name	PAREKH, Nitin
Sheet 1 of 1	Attorney Docket Number	03663 /LH

U.S. PATENT DOCUMENTS

Exam. Inits [*]	Cite No ¹	Document Number	Kind Code ²	Name of Patentee or Applicant	Publication Date MM-DD-YYYY	Relevant Portion

FOREIGN PATENT DOCUMENTS

Exam Inits [*]	Cite No ¹	Offc ³	Document Number ⁴	Kind Code ⁵	Name of Patentee or Applicant	Publication Date MM-DD-YYYY	Relevant Portion	T ⁶
		JP	2000-183089	A		06-30-2000		
		JP	2000-261141	A		09-22-2000		
		JP	2001-135747	A		05-18-2001		
		JP	2001-144213	A		05-25-2001		
		JP	2002-093945	A		03-29-2002		

Examiner Signature	Date Considered
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^{*} EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 608. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Place a check here if English translation is attached.

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